Applicant:

Kie Y. Ahn et al.

Title:

HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZrO2

Docket No.:

1303.026US1

Filed:

August 30, 2001

Examiner:

David S. Blum

Customer No.: 21186

Serial No.: 09/945535

Due Date: September 24, 2003

Group Art Unit: 2813 Confirmation No.: 2681

MS Non-Fee Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

A return postcard.

 $\underline{\mathbf{X}}$ An Amendment and Response (11 Pages).

X Communication Concerning Co-Pending Applications (3 pgs.).

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

Atty: David Č. Peterson

Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Non-Fee Amendment, Commissioner for Patents, P.O.Box 1450, Alexandria, VA 22313-1450, on this 24th day of September, 2003.

Name

Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

(GENERAL)

TECHNOLOGY CENTER 2800

S/N 09/945535 **PATENT**

ATES PATENT AND TRADEMARK OFFICE

Applicant:

Examiner: David S. Blum

Serial No.:

09/945535

Group Art Unit: 2813

Filed:

August 30, 2001

Docket: 1303.026US1

Title:

HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

COMMUNICATION CONCERNING RELATED APPLICATION(S)

insissioner for Patents
ox 1450
Indria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related option(s) in the above identified patent application: application(s) in the above-identified patent application:

Serial/Patent No. 09/944981	Filing Date August 30, 2001	Attorney Docket 1303.021US1	Title CRYSTALLINE OR AMOPHOUS MEDIUM-K GATE OXIDES, Y203 AND Gd203
10/028643	December 20, 2001	1303.030US1	LOW-TEMPERATURE GROWN HIGH QUALITY ULTRA-THIN CoTiO3 GATE DIELECTRICS
10/052983	January 17, 2002	1303.031US1	HIGHLY RELIABLE AMORPHOUS HIGH-k GATE DIELECTRIC ZrOxNy
10/027315	December 20, 2001	1303.033US1	LOW-TEMPERATURE GROWN HIGH- QUALITY ULTRA-THIN PRASEODYMIUM GATE DIELECTRICS
10/099194	March 13, 2002	1303.044US1	EVAPORATION OF Y-Si-O FILMS FOR MEDIUM-k DIELETRICS
10/081439	February 20, 2002	1303.046US1	EVAPORATED LaAIO3 FILMS FOR GATE DIELECTRICS
10/137499	May 2, 2002	1303.050US1	ATOMIC LAYER-DEPOSITED LaAlO3 FILMS FOR GATE DIELETRICS

Serial Number: 09/945535

Filing Date: August 30, 2001

<u>Title: HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2</u>

Page 2 Dkt: 1303.026US1

Title: HIGHLY RELIAE	BLE AMORPHOUS HI	GH-K GATE OXIDE ZROZ	
10/163481	June 5, 2002	1303.056US1	ATOMIC LAYER-DEPOSITED HfAIO3 FILMS FOR GATE DIELECTRICS
10/163686	June 5, 2002	1303.059US1	Pr2O3-BASED La-oxide GATE DIELECTRICS
10/209581	July 30, 2002	1303.061US1	ATOMIC LAYER DEPOSITED NANOLAMINATES OF HfO2/ZrO2 FILMS AS GATE DIELECTRICS
10/219870	August 15, 2002	1303.069US1	LANTHANIDE DOPED TiOx DIELECTRIC FILMS BY PLASMA OXIDATION
10/219878	August 15, 2002	1303.070US1	LANTHANIDE DOPED TiOx DIELECTRIC FILMS
10/229903	August 28, 2002	1303.078US1	ATOMIC LAYER DEPOSITED HISION DIELECTRIC FILMS
10/233309	August 29, 2002	1303.079US1	ATOMIC LAYER DEPOSITED LANTHANIDE DOPED TiOx DIELECTRIC FILMS
10/309583	December 4, 2002	1303.082US1	ATOMIC LAYER DEPOSITED ZR-SN- TI-O FILMS USING Til4
10/309935	December 4, 2002	1303.083US1	ATOMIC LAYER DEPOSITED Zr-Sn-Ti-O FILMS
10/379470	March 4, 2003	1303.090US1	ATOMIC LAYER DEPOSITED DIELECTRIC LAYERS
10/403734	March 31, 2003	1303.092US1	ATOMIC LAYER DEPOSITED ZrAlxOy DIELECTRIC LAYERS
10/420307	April 22, 2003	1303.097US1	ATOMIC LAYER DEPOSITED ZrTiO4 FILMS
10/602323	June 24, 2003	1303.101US1	LANTHANIDE OXIDE / HAFNIUM OXIDE DIELECTRIC LAYERS
10/602315	June 24, 2003	1303.107US1	LANTHANIDE OXIDE / HAFNIUM OXIDE DIELECTRICS

Page 3 Dkt: 1303.026US1

Serial Number: 09/945535 Filing Date: August 30, 2001

Title: HIGHLY RELIABLE AMORPHOUS HIGH-K GATE OXIDE ZRO2

09/779959	Eshanson, O
09///9939	February 9,
	2001
09/838335	April 20,
	2001
09/881408	June 13,
	2001
09/908767	July 18,
	2001
09/779959	February 9,
	2001
09/838335	April 20,
	2001
09/881408	June 13,
	2001
09/908767	July 18,
	2001

Respectfully submitted,

KIE Y. AHN ET AL.

By Applicants' Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

P.O. Box 2938

Minneapolis, MN 55402

(612) 373-6944

Date 9-24-03

David C. Peterson

Reg. No. 47,857

<u>CERTIFICATE UNDER 37 CFR 1.8:</u> The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this <u>24th</u> day of <u>September</u>, 2003.

NT-

Signature